



JB / IFCW

2891

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Confirmation No.: 8576

Nobuaki HASHIMOTO

Allowed: August 16, 2005

Group Art Unit: 2891

Application No.: 09/486,561

Examiner: D. ZARNEKE

Filed: February 29, 2000

Docket No.: 105030

For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURE THEREOF,
CIRCUIT BOARD AND ELECTRONIC INSTRUMENT

LETTER TO THE OFFICIAL DRAFTSPERSON

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please substitute the attached first sheet of formal drawings depicting Figure 1 for the corresponding drawings filed with the application. Figure 1(D) has been corrected in accordance with the Request for Approval of Drawing Correction filed May 29, 2001.

Respectfully submitted,

James A. Oliff
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JAO:CWB:LXL/tlp
Date: November 15, 2005

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